

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: DAVID J. BAIN, ET AL. )  
Serial No.: 10/710,653 ) Group Art Unit: 2836  
Filed: July 27, 2004 )  
For: PRESSURE ASSISTED WAFER )  
HOLDING APPARATUS AND ) Examiner: Roman, L.  
CONTROL METHOD ) Confirmation No.: 4652  
 )

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE

Applicants request amendment to this application under 37 CFR § 1.312.